

Journal of Materials Chemistry A

Accepted Manuscript



This is an *Accepted Manuscript*, which has been through the Royal Society of Chemistry peer review process and has been accepted for publication.

Accepted Manuscripts are published online shortly after acceptance, before technical editing, formatting and proof reading. Using this free service, authors can make their results available to the community, in citable form, before we publish the edited article. We will replace this *Accepted Manuscript* with the edited and formatted *Advance Article* as soon as it is available.

You can find more information about *Accepted Manuscripts* in the [Information for Authors](#).

Please note that technical editing may introduce minor changes to the text and/or graphics, which may alter content. The journal's standard [Terms & Conditions](#) and the [Ethical guidelines](#) still apply. In no event shall the Royal Society of Chemistry be held responsible for any errors or omissions in this *Accepted Manuscript* or any consequences arising from the use of any information it contains.

Organic Photovoltaic Cells Utilising ZnO Electron Extraction Layers Produced Through Thermal Conversion of ZnSe

AUTHOR NAMES

Edward New¹, Ian Hancox¹, Luke A. Rochford¹, Marc Walker², Chloe Argent Dearden¹, Chris F. McConville², Tim. S. Jones^{1}*

AUTHOR ADDRESS

¹Department of Chemistry, University of Warwick, Coventry, CV4 7AL, UK

²Department of Physics, University of Warwick, Coventry, CV4 7AL, UK

KEYWORDS Organic Photovoltaic, ZnO, ZnSe, boron subphthalocyanine, SubPc, metal oxide, electron extracting layer, buffer layer

ABSTRACT

In this work, a thin ZnSe layer was deposited in vacuum and then thermally annealed in air to provide an efficient electron extraction layer for an inverted organic photovoltaic (OPV) cell. Annealing the ZnSe film at 450 °C (ZnSe_(450 °C)) increased the device performance and gave an efficiency of 2.83%. X-ray photoelectron spectroscopy (XPS) measurements show that the increased device performance upon annealing at 450 °C is due to the thermal conversion of ZnSe to ZnO. ZnO has a wider band gap than ZnSe, which allows for more light to reach the

photoactive layer. The electronic structure of the treated ZnSe films were explored by ultraviolet photoemission spectroscopy (UPS) which showed that the ZnSe_(450 °C) films had a Fermi level close to the conduction band edge, allowing for efficient electron extraction compared to the energetic barrier for extraction formed at the ZnSe_(RT) / organic interface.

Introduction

Organic photovoltaic (OPV) cells have received significant attention as an alternative renewable energy source due to their potential for low cost fabrication and fast energy payback times.¹ In recent years efficiencies have risen above the 10% barrier using many different architectures and materials, with the record power conversion efficiency of 12% achieved for a multi-junction device.² As well as improving the design of photoactive materials to enable higher photocurrents, the design of the interlayers is important for maximising the built-in field and providing lossless extraction at the organic / electrode interface.^{3,4} These layers facilitate electron or hole extraction to the respective electrodes.

Hole extraction layers typically consist of either solution processed poly(3,4-ethylenedioxythiophene):poly(styrenesulfonate) (PEDOT:PSS) or high work function metal oxides such as MoO_x, V₂O_x, WO_x, which can be deposited either by vacuum deposition or solution methods.⁵⁻¹¹ For electron extraction, most small molecule OPV devices use an organic exciton blocking layer such as bathocuproine (BCP), which transports charge through metal defects caused by cathode deposition.^{12, 13} Other electron extraction layers used include low work function metal oxides such as TiO_x and ZnO, which have high stability and high electron mobility.¹⁴⁻¹⁸ These can be processed by many different methods including; solution from nanoparticles, sol-gel, electrodeposition, pulsed laser deposition and atomic layer deposition.¹⁹⁻²⁴ Whilst these approaches are all capable of producing efficient electron extraction layers for OPVs, they each have drawbacks. Control and reproducibility to sub

nanometre accuracy is hard to achieve with layers prepared from nanoparticles and sol-gels. Additionally, these solution processed methods require further optimisation for changes in laboratory temperature and humidity, which may also vary during a single day, as well as with substrate surface conditions. Pulsed laser deposition can suffer from small areas of uniformity and requires careful control of several parameters during growth. Thermal evaporation would be an alternative method to deposit such interfacial layers with sub nanometre accuracy, with film homogeneity across a wide area and without dependence on laboratory conditions. Thermal evaporation of interlayers would also allow reproducible scale-up of layer fabrication as well as the ability to deposit through shadow masks, for more complex modular structures. However, the high evaporation temperatures of both ZnO and TiO_x prevent common use by vacuum deposition in conjunction with small molecule vacuum evaporated OPVs. Using other chalcogenide derivatives of Zn, such as ZnS and ZnSe which have lower evaporation temperatures, would allow for a wide band gap, low work function material to be thermally evaporated. By using the same process as the organic layers, a high degree of control over layer thickness and homogeneity can be obtained. Recent work has used vacuum deposition of ZnS as an electron extraction layer, although it requires the use of an Al₂S₃ dopant for application in OPV cells.²⁵

In this paper we have investigated the deposition of thin ZnSe layers by thermal evaporation in vacuum. The layers were subsequently heat treated under ambient conditions at a range of temperatures before inclusion in inverted small molecule OPV cells. The variation of cell performance with heat treatment temperature was investigated in terms of layer stoichiometry, electronic structure and surface morphology. The favourable change in electronic structure with heating at 450 °C was due to the thermal conversion of the ZnSe interlayer to ZnO, resulting in a highly transparent, low work function electron extraction layer. This method of producing a thin, homogeneous ZnO layer led to improved efficiency

for inverted device structures and can potentially be applied to other solar and organic electronic applications.

Experimental

ZnSe (Sigma Aldrich, 99.99 %) films were produced by vacuum evaporation on indium tin oxide (ITO) covered glass substrates ($15 \Omega \text{ sq}^{-1}$, Thin Film Devices) using a Kurt J. Lesker Spectros system with a base pressure of 1×10^{-8} mbar. Each ZnSe film was then thermally annealed in air for 30 min. For OPV device fabrication, the annealed ZnSe films were placed back in the vacuum chamber for subsequent deposition of organic layers. Of the organic materials used in these experiments, C_{60} (Nano-C Inc, 99.5 %) was purified by vacuum gradient sublimation prior to deposition, whilst boron subphthalocyanine chloride (SubPc, Lumtec, 99 %) and molybdenum oxide (MoO_x , Aldrich, 99.99 %) were used as received. The Al cathode was deposited *in-situ* through a shadow mask, giving devices with an active area of 0.16 cm^2 . Where direct comparisons between electron extracting layer treatments are made, the common layers in all cells within the data set were deposited simultaneously to avoid batch-to-batch variations.

The current–voltage (J – V) characteristics of the OPV cells were measured under simulated AM1.5G solar illumination at 100 mW cm^{-2} from a Newport Oriel solar simulator using a Keithley 2400 sourcemeter for current detection.

The X-ray photoelectron spectroscopy (XPS) measurements were carried out following transfer through air and loading into a UHV system with a base pressure of $\sim 2 \times 10^{-11}$ mbar. The sample was excited with X-rays from a monochromated Al $\text{K}\alpha$ source ($h\nu = 1486.6 \text{ eV}$), with the photoelectrons being detected at normal emission using an Omicron Sphera 7 channel concentric hemispherical electron analyser. The combined energy resolution of the

experiment was calculated to be 0.47 eV based on calibration scans with a polycrystalline Ag sample.

Ultra-violet photoemission spectroscopy (UPS) measurements were carried out using a custom multi-chamber ultra-high vacuum (UHV) system with a base pressure of $\sim 1 \times 10^{-10}$ mbar. UPS spectra were recorded using a SPECS PHOIBOS 100 hemispherical electron energy analyser with excitation at 21.21 eV from a He I gas discharge source.

Atomic force microscopy (AFM) images were obtained from an Asylum Research MFP-3D (Santa Barbara, USA) in AC mode, using AC240TS cantilevers.

Results and Discussion

OPV Cells Incorporating ZnSe Layers

The device structure of the inverted OPV cell used in this study is shown in Figure 1a. The optimised structure comprised of ITO / ZnSe_(x °C) (8 nm) / C₆₀ (35 nm) / SubPc (14 nm) / MoO_x (15 nm) / Al, where ZnSe_(x °C) refers to the post deposition annealing temperatures, which were carried out at 250 °C, 350 °C and 450 °C, whilst also compared to an as-deposited layer (RT). The J - V characteristic plots for the OPV cells with a range of ZnSe annealing temperatures are shown in Figure 1b, with the performance parameters summarised in Table 1 (additional cell data shown in Supporting Information Figure S1). The ZnSe_(RT) cell displays a very poor efficiency of 0.03 % and the low performance parameters are illustrated by the S-shape J - V curve reducing dramatically before J_{SC} . This is indicative of a blocking barrier to electron extraction and results in a high series resistance (R_s).^{26, 27} Annealing the ZnSe layer considerably increases the photocurrent, with the ZnSe_(250 °C) and ZnSe_(350 °C) cells having a J_{SC} of 3.22 mAcm⁻² and 3.75 mAcm⁻² respectively. The

performance of these cells is still hampered by the drop off in photocurrent after J_{SC} and low V_{OC} values of 0.44 V and 0.50 V respectively. The low currents in the $J-V$ plot after V_{OC} of these cells suggest there is a barrier for injection at the ITO / ZnSe_(250 °C / 350 °C) interface.^{26, 27} The ZnSe_(450 °C) cell shows the highest performance of all of the devices with an efficiency of 2.83 %. All of the device parameters are also improved with a high V_{OC} of 1.02 V and a large FF of 0.59 achieved. The ZnSe_(450 °C) cell also displayed the highest photocurrent of the ZnSe treatments, with 4.59 mAcm⁻², an improvement of ~ 20 % over the ZnSe_(350 °C) cell. The optimum efficiency was achieved after 2 minutes of light soaking to improve the series resistance, a phenomenon which has been observed previously in metal chalcogenide interlayers.^{28, 29} The efficiency of this device is comparable to typical SubPc/C₆₀ regular architectures with a MoO_x hole extraction layer.³⁰ Annealing the ZnSe to a higher temperature of 550 °C had a detrimental effect upon device performance (Supporting Information Figure S2).

The transmittance spectra of 80 nm ZnSe_(RT), ZnSe_(250 °C), ZnSe_(350 °C) and ZnSe_(450 °C) films on quartz substrates are displayed in Figure 2, with thicker layers used to obtain the bandgap (E_g) of each. There is a large difference in transmittance of the films, with those treated at room temperature to 350 °C absorbing strongly below 500 nm and more weakly in the red part of the spectrum, whereas the ZnSe_(450 °C) film is highly transmissive in the visible range above 350 nm. This change in transmittance with thermal annealing of the ZnSe can also be seen in the inset photograph in Figure 2, with the ZnSe_(RT), ZnSe_(250 °C) and ZnSe_(350 °C) films displaying a green colour but the ZnSe_(450 °C) film being highly transparent. The optical band gap of the two films can be estimated from the transmittance plot from the onset in absorption. This gives values of 2.4 eV for the ZnSe_(RT) film and 3.1 eV for the ZnSe_(450 °C) film, signifying a change in the film composition.

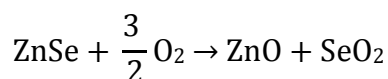
Determination of ZnSe Composition

With the OPV cells fabricated with different ZnSe thermal treatments showing stark performance differences, alongside a significant change in transmittance, the factors influencing the changes were explored. XPS measurements were carried out in order to elucidate the effect of the heat treatment on the stoichiometry and composition of the films. XPS spectra displaying the Se 3d and O 1s regions of the films treated at each temperature are presented in Figures 3 and 4 respectively. XPS spectra for the Zn 2p regions can be found in the Supporting Information Figure S3. In each instance, Shirley background subtractions were used with peaks fitted by a Lorentzian-Gaussian combination, which was kept consistent for each treatment.

The Se 3d region shown in Figure 3 displays two features, one centred at 59.0 eV binding energy and the other at 54.0 eV. Each feature comprises two peaks due to the spin orbit splitting of the Se 3d level. At every treatment temperature the magnitude of the feature at 59.0 eV remains similar, with components at 59.6 eV and 58.7 eV. These peaks can be attributed to the Se 3d_{1/2} and 3d_{3/2} levels in SeO₂.³¹ However, the contribution from the feature centred at 54.0 eV varies greatly with film treatment. The ZnSe_(RT) and ZnSe_(250 °C) layers show a large feature of similar dimensions. The peaks at 54.7 eV and 53.8 eV binding energy are due to the 3d_{1/2} and 3d_{3/2} splitting of the Se 3d attributed to ZnSe.³¹ For the ZnSe_(350 °C) layers the magnitude of the feature is noticeably smaller, and for ZnSe_(450 °C) layers the feature is almost negligible. This would suggest that the films treated at higher temperatures have significantly decreased ZnSe content.

In order to further investigate this change in stoichiometry on thermal processing, a spectrum of the O 1s region for each layer was obtained, and is shown in Figure 4. The ZnSe_(RT) and

ZnSe_(250 °C) layers show only two major components in the O 1s region, centred at 531.3 eV and 531.1 eV, which are due to contaminants and SeO₂ respectively.³¹ A further smaller component is shown at ~ 534.0 eV for each case due to water on the surface. For ZnSe_(350 °C) layers, an additional peak is shown at 530.2 eV which is attributed to the presence of ZnO. For the ZnSe_(450 °C) layers, the ZnO feature at 530.2 eV becomes dominant. Since the Se 3d region indicated only a small fraction of the ZnSe remained within the films treated at 450 °C, this would suggest that the ZnSe_(450 °C) layer has been nearly fully converted to ZnO (we will continue to refer to the ZnO layer formed as ZnSe_(450 °C) for consistency). Thermal conversion of ZnSe to ZnO has been shown by annealing in air at 400-600 °C.³² The reaction follows the equation:



The SeO₂ is gaseous so is driven off, leaving behind ZnO on the substrate.

To quantify the relative stoichiometry after each treatment condition, the relative sensitivity factors (rsf) for each component were utilised. Table 2 displays the relative composition found for each environment from the XPS spectra. The percentage fraction of SeO₂ is also shown. The ZnSe_(RT) and ZnSe_(250 °C) layers contain negligible ZnO, with ZnSe in a Zn : Se ratio of 0.86 : 1 and 0.93 : 1 respectively. This indicates that the ZnSe layers are slightly Se rich. Treatment at 350 °C results in a layer composed of both ZnSe and ZnO. The ratio of Se 3d (ZnSe) : O 1s (ZnO) is shown to be 1.27 : 1. Therefore, nearly half of the ZnSe in the layer is converted to ZnO. The ZnSe_(450 °C) layer only contains 0.6 % ZnSe content from the Se 3d region. However, ZnO is present in a Zn : O ratio of 0.83 : 1. Thus, the heat treatment at this temperature produces an oxygen rich ZnO film.

These changes in layer composition with heat treatment help explain the widening of the bandgap, E_g , from 2.4 eV for ZnSe_(RT) to 3.1 eV for ZnSe_(450 °C). However, ZnSe is known to exhibit a much smaller E_g than ZnO when each material is deposited via other methods, hence the widening of the E_g on heat treatment due to conversion from ZnSe to ZnO is to be expected.^{3,33} The additional transparency of the wide band gap ZnSe_(450 °C) film is beneficial for use as an electron extracting layer, allowing the increase in cell J_{SC} shown in Table 1.

Electronic Structure of the ZnSe Films

The electronic structure of an electron extracting layer can also have a major influence on the cell performance as displayed in Figure 1.^{34,35} In order to maximise the built-in field (V_{bi}) of the OPV cell, thus minimising losses in V_{OC} , the interfacial contacts either side of the photoactive material must have favourable energetic alignment with the corresponding organic. This is described elegantly by the integer charge model proposed by Crispin *et. al.* and Braun *et. al.*^{36,37} In the case of hole extracting materials, such as the MoO_x layer used in cells here, the work function must be larger than the positive integer charge transfer (ICT) state of the donor organic.³⁰ This is typically 0.1 - 0.3 eV above the highest occupied molecular orbital (HOMO) onset for the organic material. For the electron extracting material, the work function of the interlayer must be smaller than the negative ICT of the acceptor organic, typically 0.1 - 0.3 eV below the lowest unoccupied molecular orbital (LUMO) of the organic. The commonly used fullerene acceptor materials employed in OPV cells are C₆₀ (LUMO – 4.4 to 4.5 eV) and PCBM (LUMO - 4.3 eV).³⁸⁻⁴⁰ In addition, to extract charges efficiently the position of the conduction band (CB) in relation to the organic acceptor materials LUMO needs to be considered. If there is an energetic barrier to electron extraction then the layer will be detrimental to cell performance.^{26,27}

UPS measurements were obtained in order to probe the electronic structure of the interface between the ZnSe layers and the organic acceptor material. The secondary electron cut-off and valence band UPS spectra shown in Figure 5 were used to determine the electronic properties of the ZnSe_(RT) and ZnSe_(450 °C) layers. Valence band spectra for ZnSe_(250 °C) and ZnSe_(350 °C) layers are shown in Supporting Information Figure S4. In Figure 5a, the secondary electron cut-off region indicates the work function of each sample. The work function of the ZnSe_(RT) layer was found to be 3.6 eV, whilst ZnSe_(450 °C) layers possess a work function of 3.4 eV. This indicates that both layers have a favourable work function for use as electron extracting materials.

A more significant difference between the treatments is expressed in the valence band (VB) UPS spectra, shown in Figure 5b. The untreated ZnSe layer (black line) has a valence band onset 1.1 eV below the Fermi level, yielding an ionization potential (*IP*) of 4.7 eV. With the position of the VB determined, we can use the optical band gap measurement to predict the position of the CB of the material. Therefore, the band gap of 2.4 eV indicates the electron affinity (*EA*) of the ZnSe_(RT) is 2.3 eV. Due to the positioning of the valence band in relatively close proximity to the Fermi level (E_F) in ZnSe_(RT), the layer will be unable to block holes from the HOMO of the organic layers. This would lead to detrimental quenching of excitons at this interface. More significantly, the CB of ZnSe_(RT) is 1.3 eV above the E_F of the layer. Therefore, a large energetic barrier to electron extraction from the organic LUMO is formed at the interface. This is shown with comparison to literature values for the electronic structure of C₆₀ in Figure 6a, indicating a barrier of 0.8 eV.⁴⁰ This energetic barrier to electron extraction explains the poor electron extracting characteristics of the ZnSe_(RT) layer, and consequently is the cause of the inefficient OPV cell performance shown in Figure 1b.

In stark contrast, the valence band onset of the layer treated at 450 °C (blue line) is 3.3 eV below the E_F of the $\text{ZnSe}_{(450\text{ }^\circ\text{C})}$ layer (Figure 5a). This indicates the material possesses an IP of 6.7 eV, forming a large energetic barrier to hole extraction at the interface with the organic acceptor. This favourable ability to block hole extraction is shown schematically in Figure 6b, with an energetic barrier of ~ 1.8 eV when compared to the literature values for the electronic structure of C_{60} .⁴⁰ The measurements also show a highly n-type character, with the CB of $\text{ZnSe}_{(450\text{ }^\circ\text{C})}$ close to the E_F of the layer. This is unsurprising given previous reports of the electronic structure of ZnO films deposited via other methods.^{3, 18} The position of the CB in $\text{ZnSe}_{(450\text{ }^\circ\text{C})}$ layers allows energetically favourable electron extraction with C_{60} (Figure 6b), hence the excellent OPV performance shown for deposition on $\text{ZnSe}_{(450\text{ }^\circ\text{C})}$ layers in Figure 1.

Topography of the Layers

Surface morphology of the electron extracting layers may also influence cell performance. The surface topography of the layers was obtained using an AFM in AC mode, with the topographical images for $\text{ZnSe}_{(\text{RT})}$ and $\text{ZnSe}_{(450\text{ }^\circ\text{C})}$ layers shown in Figure 7. These images show that the surface morphology of the layers differ, with surface roughness (R_q) values of 3.1 nm and 2.5 nm for $\text{ZnSe}_{(\text{RT})}$ and $\text{ZnSe}_{(450\text{ }^\circ\text{C})}$ layers respectively. The $\text{ZnSe}_{(\text{RT})}$ film (Figure 7a) shows a smooth surface with small ‘dot’ features up to 20 nm high and 80 nm wide, with an average density of 11.5 ‘dots’ μm^{-2} . Even without taking tip convolution effects into account, these ‘dots’ only make up $\sim 4\%$ of the volume of the 8 nm ZnSe film deposited on the ITO surface. Upon heat treatment at 450 °C the ‘dots’ are no longer present (Figure 7b), leading to the lower R_q values obtained. However, since both layers provide a relatively smooth surface, the morphologies should not influence OPV device performance greatly, especially in comparison to the differences in the electronic properties of the layers.

Conclusions

This work has focused on the fabrication of thermally evaporated electron extracting materials based on ZnSe for use in OPV cells. Thin layers of ZnSe were grown and heat treated prior to use in OPV cells. The OPV cell performance was found to dramatically increase upon heat treatment of the ZnSe electron extraction layer from 0.03 % for cells on the ZnSe_(RT) layers, to 2.83 % on the ZnSe_(450 °C) layer. The widening of the E_g featured in the transmittance when comparing ZnSe_(RT) to ZnSe_(450 °C) layers was shown to be due to the thermal oxidation of ZnSe to ZnO. While the UPS measurements indicate that both ZnSe_(RT) and ZnSe_(450 °C) layers have low work functions that are favourable for electron extracting materials, the position of the VB and CB for each layer influences cell performance. The position of the CB for the ZnSe_(RT) layer causes an energetic barrier to electron extraction, whereas the close proximity of the CB to the E_F in ZnSe_(450 °C) films allows efficient extraction. This results in poor OPV cell performances when using ZnSe_(RT) layers, but efficient performances upon heat treatment to form ZnSe_(450 °C) electron extracting layers. This approach allows for sub nanometre control over interfacial layer thickness and due to the ease of thermal deposition and heat treatment, these films show promise as possible electron extracting layers during the scale up of OPV manufacture and for use in other organic electronic applications.

Associated Content

Supporting Information

Electronic supplementary information (ESI) available: Additional cell data, UPS valence band spectra and XPS spectra. See DOI:

Author information**Corresponding Author**

*E-mail t.s.jones@warwick.ac.uk

Notes

The authors declare no competing financial interest.

Acknowledgements

E. New and I. Hancox are supported by TSB project “Development of Prototype High Efficiency Multi-Junction Organic Solar Cells (#100900). The XPS system used in this research was funded through the Science City Research Alliance (SCRA) Advanced Materials Project 1: “Creating and Characterizing Next Generation of Advanced Materials” with support from Advantage West Midlands (AWM) and the European Regional Development Fund (ERDF).

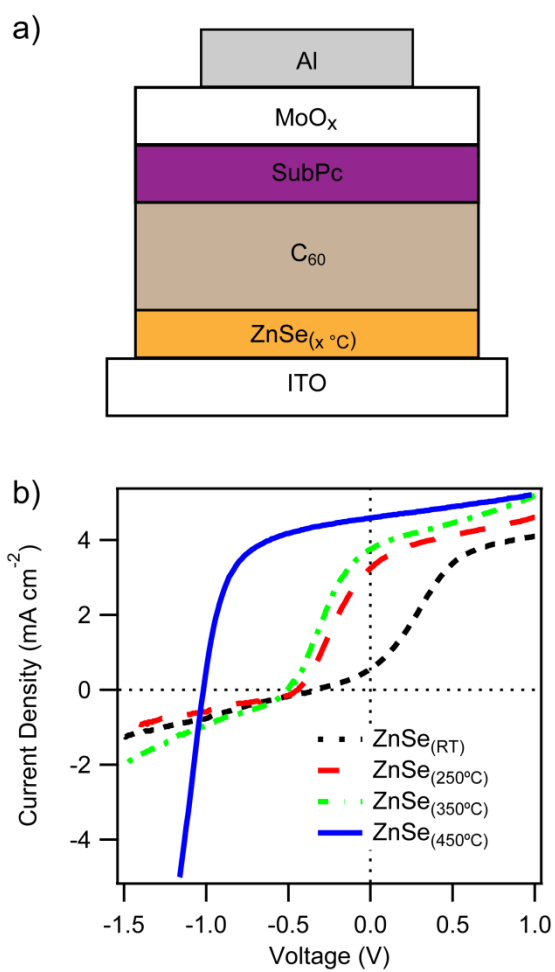


Figure 1. a) A schematic of the OPV cell design. b) J - V characteristic plots for the different ZnSe annealing temperatures.

Table 1. OPV cell performance parameters for each annealing temperature, averaged over a minimum of 6 devices fabricated simultaneously with standard deviations in parentheses. ^a

ZnSe_(450 °C) cell after 2 min AM1.5G 100 mW/cm² light soak.^{28, 29}

ZnSe layer treatment	J_{SC} (mA cm ⁻²)	V_{OC} (V)	FF	η (%)
ZnSe _(RT)	0.53 (±0.13)	0.33 (±0.04)	0.19 (±0.01)	0.03 (±0.01)
ZnSe _(250 °C)	3.22 (±0.23)	0.44 (±0.04)	0.27 (±0.01)	0.39 (±0.07)
ZnSe _(350 °C)	3.75 (±0.13)	0.50 (±0.12)	0.34 (±0.02)	0.64 (±0.16)
^a ZnSe _(450 °C)	4.59 (±0.03)	1.02 (±0.00)	0.59 (±0.01)	2.83 (±0.04)

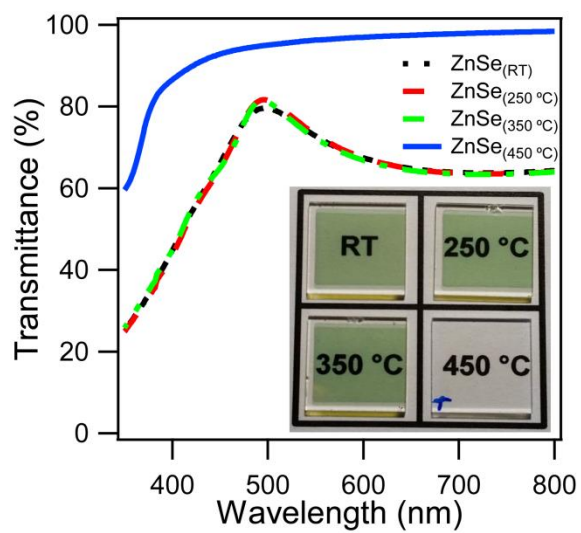


Figure 2. Transmittance spectra of 80 nm $\text{ZnSe}_{(\text{RT})}$, $\text{ZnSe}_{(250\text{ }^\circ\text{C})}$, $\text{ZnSe}_{(350\text{ }^\circ\text{C})}$ and $\text{ZnSe}_{(450\text{ }^\circ\text{C})}$ films on quartz substrates. Inset shows a photograph of the samples.

Table 2. Table showing the layer composition for each treatment of the near surface region, obtained through fitting of XPS data in combination with the rsf of each component.

ZnSe layer treatment	Se 3d (ZnSe 54.7, 53.8 eV) %	Se 3d (SeO ₂ 59.6, 58.7 eV) %	O 1s (ZnO 530.2 eV) %	Zn 2p (Zn 1044.7, 1021.6 eV) %
ZnSe _(RT)	49.9	4.1	0.0	43.0
ZnSe _(250 °C)	48.2	3.5	0.0	44.0
ZnSe _(350 °C)	23.3	5.1	18.4	49.4
ZnSe _(450 °C)	0.6	2.7	51.5	42.7

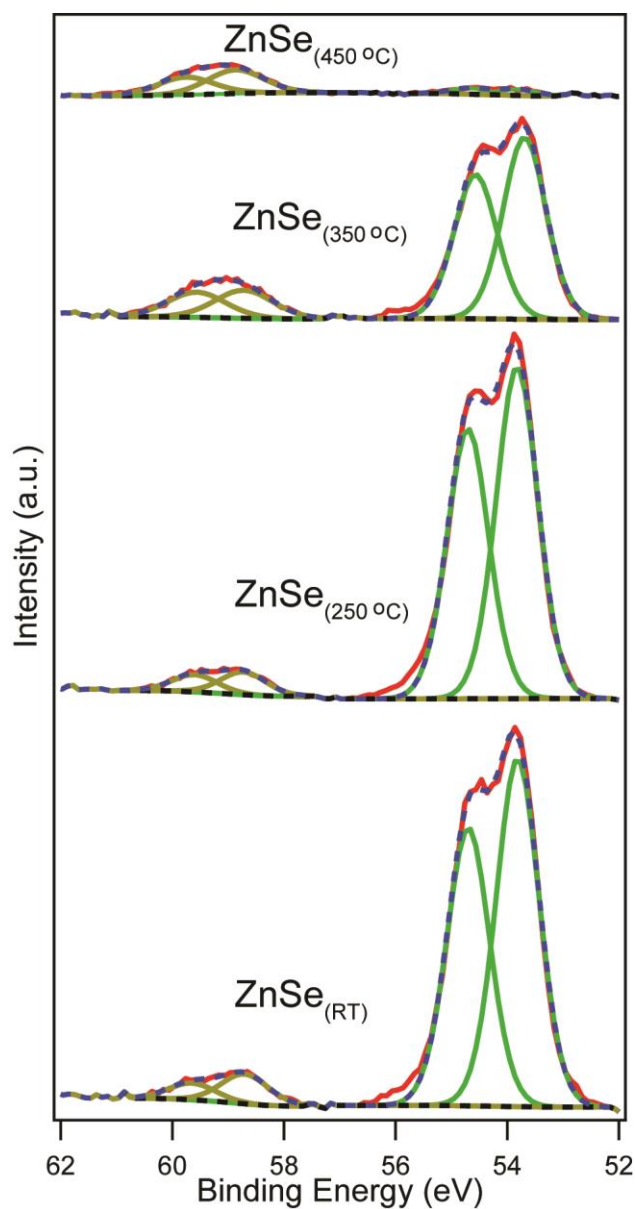


Figure 3. XPS spectra of the Se 3d region obtained for each layer treatment. Red lines indicate experimental data, dashed black lines the Shirley backgrounds, dashed blue lines the fitting envelope, with gold and green lines representing the fitting for SeO₂ and ZnSe environment contributions respectively.

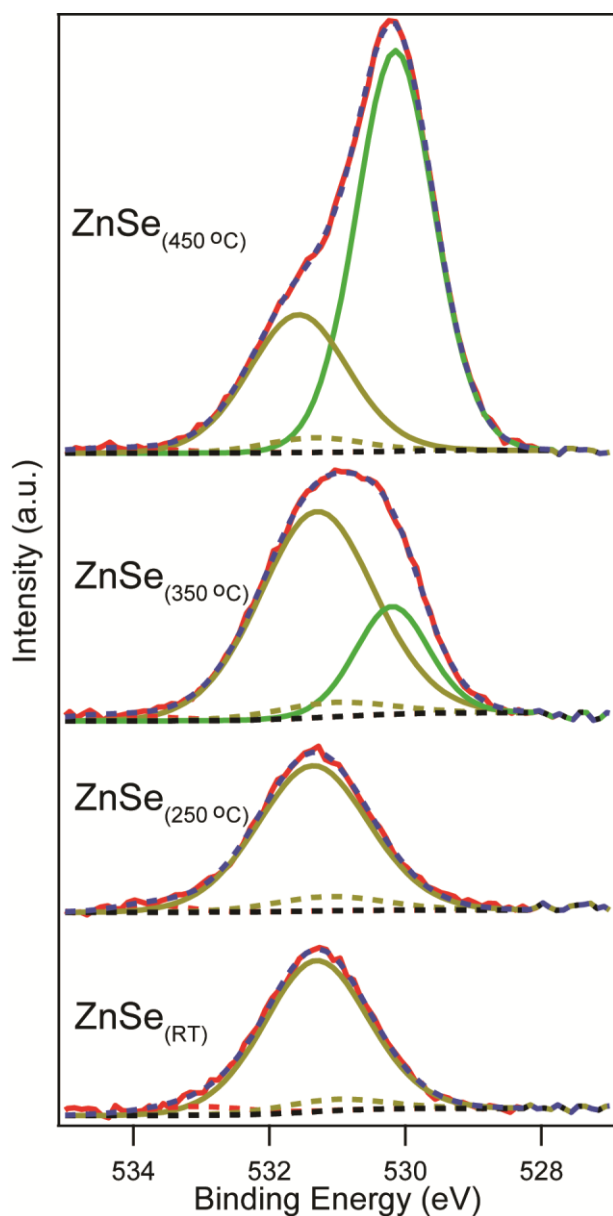


Figure 4. XPS spectra of the O 1s region obtained for each layer treatment. Red lines indicate experimental data, dashed black lines the Shirley backgrounds, dashed blue lines the fitting envelope, with gold solid and dotted lines representing the fitting for contaminant and SeO_2 respectively, red dotted lines the water contribution and green lines representing the fitting for the ZnO environment contributions.

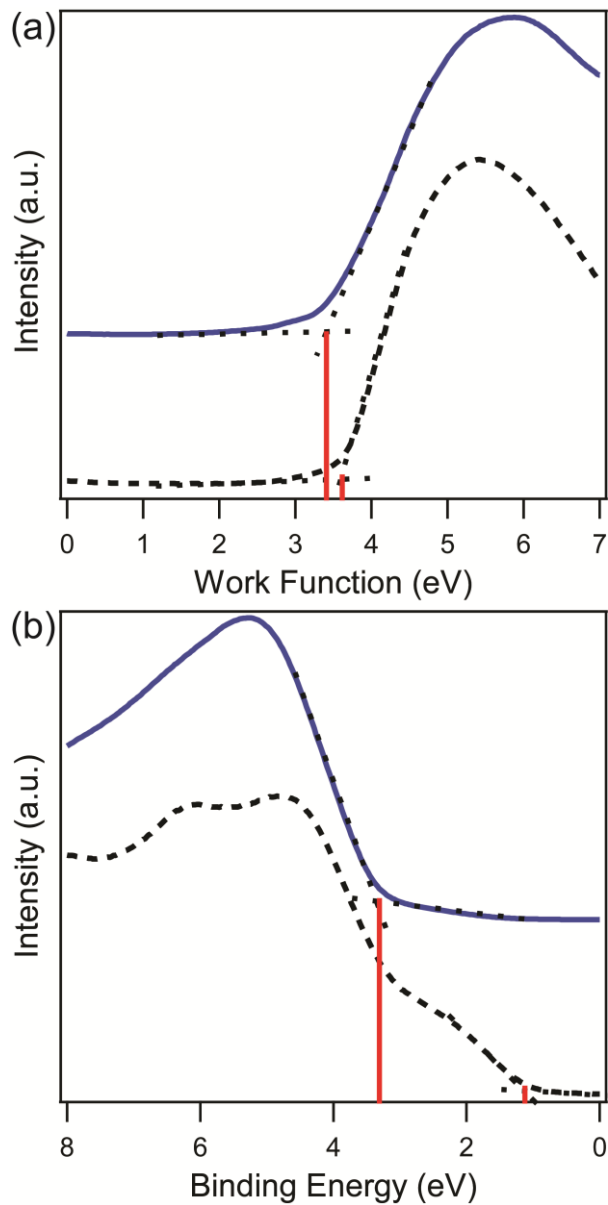


Figure 5. Onset of the secondary electron cut-off (a) and valence band (b) UPS spectra for 8nm ZnSe_(RT) films (black dashed lines) and 8 nm ZnSe_(450 °C) films (blue solid lines), both deposited onto ITO substrates. Solid red and dashed black lines show fitting of the data.

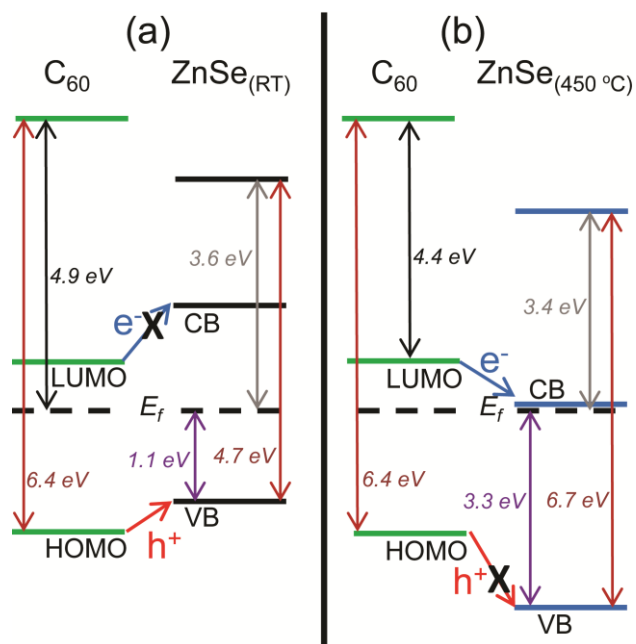


Figure 6. Schematic of hole extraction routes at the C₆₀/electron extracting interface for ZnSe_(RT) (a) and ZnSe_(450 °C) (b) layers. Values for C₆₀ electronic structure taken from measurements reported in literature.⁴⁰

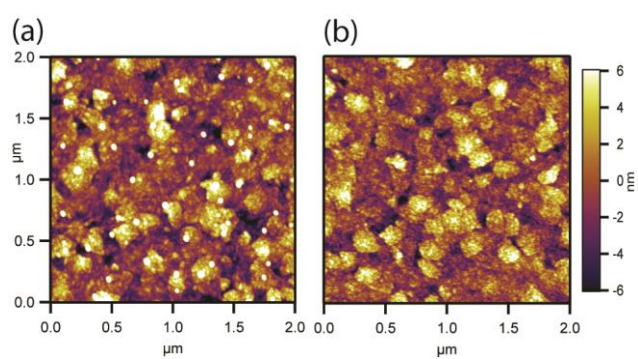


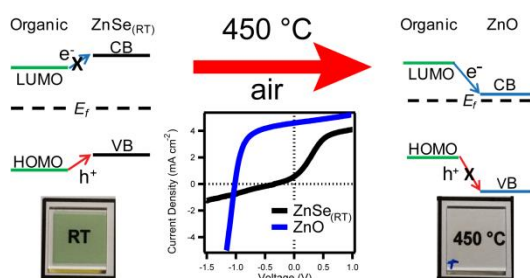
Figure 7. 2.0 μm AFM topographical images of (a) ITO / ZnSe_(RT) and (b) ITO / ZnSe_(450 °C), with the same height scale (± 6 nm).

References

1. N. Espinosa, M. Hosel, D. Angmo and F. C. Krebs, *Energy Environ. Sci.*, 2012, **5**, 5117-5132.
2. Heliatek Press Release 16/01/2013 www.heliatek.com accessed 09/04/2014
3. M. T. Greiner, M. G. Helander, W. M. Tang, Z. B. Wang, J. Qiu and Z. H. Lu, *Nat. Mater.*, 2012, **11**, 76-81.
4. I. Hancox, L. A. Rochford, D. Clare, M. Walker, J. J. Mudd, P. Sullivan, S. Schumann, C. F. McConville and T. S. Jones, *The Journal of Physical Chemistry C*, 2013, **117**, 49-57.
5. Y. Kim, A. M. Ballantyne, J. Nelson and D. D. C. Bradley, *Organic Electronics*, 2009, **10**, 205-209.
6. V. Shrotriya, G. Li, Y. Yao, C. W. Chu and Y. Yang, *Applied Physics Letters*, 2006, **88**, 073508.
7. I. Hancox, L. A. Rochford, D. Clare, P. Sullivan and T. S. Jones, *Applied Physics Letters*, 2011, **99**, 013304.
8. M. Vasilopoulou, G. Papadimitropoulos, L. C. Palilis, D. G. Georgiadou, P. Argitis, S. Kennou, I. Kostis, N. Vourdas, N. A. Stathopoulos and D. Davazoglou, *Organic Electronics*, 2012, **13**, 796-806.
9. J. Meyer, S. Hamwi, M. Kroger, W. Kowalsky, T. Riedl and A. Kahn, *Advanced Materials*, 2012, **24**, 5408-5427.
10. M. D. Irwin, B. Buchholz, A. W. Hains, R. P. H. Chang and T. J. Marks, *Proc. Natl. Acad. Sci. U. S. A.*, 2008, **105**, 2783-2787.
11. E. L. Ratcliff, J. Meyer, K. X. Steirer, A. Garcia, J. J. Berry, D. S. Ginley, D. C. Olson, A. Kahn and N. R. Armstrong, *Chem. Mat.*, 2011, **23**, 4988-5000.
12. B. P. Rand, J. Li, J. G. Xue, R. J. Holmes, M. E. Thompson and S. R. Forrest, *Advanced Materials*, 2005, **17**, 2714-2718.
13. H. Gommans, B. Verreert, B. P. Rand, R. Muller, J. Poortmans, P. Heremans and J. Genoe, *Adv. Funct. Mater.*, 2008, **18**, 3686-3691.
14. J. Y. Kim, S. H. Kim, H. H. Lee, K. Lee, W. L. Ma, X. Gong and A. J. Heeger, *Advanced Materials*, 2006, **18**, 572-576.
15. J. G. Li, S. Kim, S. Edington, J. Nedy, S. Cho, K. Lee, A. J. Heeger, M. C. Gupta and J. T. Yates, *Sol. Energy Mater. Sol. Cells*, 2011, **95**, 1123-1130.
16. H. Kim, J. Hwa Seo and S. Cho, *Applied Physics Letters*, 2011, **99**, 213302.
17. C. Waldauf, M. Morana, P. Denk, P. Schilinsky, K. Coakley, S. A. Choulis and C. J. Brabec, *Applied Physics Letters*, 2006, **89**, 233517.
18. S. Schumann, R. Da Campo, B. Illy, A. C. Cruickshank, M. A. McLachlan, M. P. Ryan, D. J. Riley, D. W. McComb and T. S. Jones, *J. Mater. Chem.*, 2011, **21**, 2381-2386.
19. J. Gilot, I. Barbu, M. M. Wienk and R. A. J. Janssen, *Applied Physics Letters*, 2007, **91**, 113520.
20. M. S. White, D. C. Olson, S. E. Shaheen, N. Kopidakis and D. S. Ginley, *Applied Physics Letters*, 2006, **89**, 143517.
21. B. N. Illy, A. C. Cruickshank, S. Schumann, R. Da Campo, T. S. Jones, S. Heutz, M. A. McLachlan, D. W. McComb, D. J. Riley and M. P. Ryan, *J. Mater. Chem.*, 2011, **21**, 12949-12957.
22. J. B. Franklin, B. Zou, P. Petrov, D. W. McComb, M. P. Ryan and M. A. McLachlan, *J. Mater. Chem.*, 2011, **21**, 8178-8182.
23. H. Cheun, C. Fuentes-Hernandez, Y. H. Zhou, W. J. Potscavage, S. J. Kim, J. Shim, A. Dindar and B. Kippelen, *J. Phys. Chem. C*, 2010, **114**, 20713-20718.

24. C. A. Dearden, M. Walker, N. Beaumont, I. Hancox, N. K. Unsworth, P. Sullivan, C. F. McConville and T. S. Jones, *Physical Chemistry Chemical Physics*, 2014, **16**, 18926-18932.
25. C. J. Traverse, M. Young, S. Wagner, P. Zhang, P. Askeland, M. C. Barr and R. R. Lunt, *Journal of Applied Physics*, 2014, **115**, 194505.
26. W. Tress, K. Leo and M. Riede, *Adv. Funct. Mater.*, 2011, **21**, 2140-2149.
27. W. Tress and O. Inganäs, *Sol. Energy Mater. Sol. Cells*, 2013, **117**, 599-603.
28. H. Schmidt, K. Zilberberg, S. Schmale, H. Flügge, T. Riedl and W. Kowalsky, *Applied Physics Letters*, 2010, **96**, 243305.
29. J. Gilot, M. M. Wienk and R. A. J. Janssen, *Applied Physics Letters*, 2007, **90**, 143512.
30. I. Hancox, P. Sullivan, K. V. Chauhan, N. Beaumont, L. A. Rochford, R. A. Hatton and T. S. Jones, *Organic Electronics*, 2010, **11**, 2019-2025.
31. M. Shenasa, S. Sainkar and D. Lichtman, *Journal of Electron Spectroscopy and Related Phenomena*, 1986, **40**, 329-337.
32. K. Tomura, M. Ohnishi and Yoshizawa, M., *Japanese Journal of Applied Physics*, 1974, **13**, 939-943.
33. C. D. Lokhande, P. S. Patil, H. Tributsch and A. Ennaoui, *Sol. Energy Mater. Sol. Cells*, 1998, **55**, 379-393.
34. E. L. Ratcliff, B. Zacher and N. R. Armstrong, *J. Phys. Chem. Lett.*, 2011, **2**, 1337-1350.
35. R. Po, C. Carbonera, A. Bernardi and N. Camaioni, *Energy Environ. Sci.*, 2011, **4**, 285-310.
36. A. Crispin, X. Crispin, M. Fahlman, M. Berggren and W. R. Salaneck, *Applied Physics Letters*, 2006, **89**, 213503.
37. S. Braun, W. R. Salaneck and M. Fahlman, *Advanced Materials*, 2009, **21**, 1450-1472.
38. Y. Kim, M. Shin, I. Lee, H. Kim and S. Heutz, *Applied Physics Letters*, 2008, **92**, 093306.
39. J. Y. Kim, K. Lee, N. E. Coates, D. Moses, T.-Q. Nguyen, M. Dante and A. J. Heeger, *Science*, 2007, **317**, 222-225.
40. S. W. Cho, L. F. J. Piper, A. DeMasi, A. R. H. Preston, K. E. Smith, K. V. Chauhan, P. Sullivan, R. A. Hatton and T. S. Jones, *The Journal of Physical Chemistry C*, 2010, **114**, 1928-1933.

TOC



A thin ZnSe layer was deposited by thermal evaporation in vacuum and thermally annealed in air to provide an efficient ZnO electron extraction layer for an inverted small molecule organic photovoltaic cell.